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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
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10/807,259

03/24/2004

Atsushi Watanabe

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STAAS & HALSEY LLP
SUITE 700
1201 NEW YORK AVENUE, N.W.
WASHINGTON, DC 20005

EXAMINER

PARK, EDWARD

ART UNIT

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PAPER

Please find below and/or attached an Office communication concerning this application or proceeding.

The time period for reply, if any, is set in the attached communication.

Office Action Summary	Application No. 10/807,259	Applicant(s) WATANABE ET AL.	
	Examiner EDWARD PARK	Art Unit 2624	

-- The MAILING DATE of this communication appears on the cover sheet with the correspondence address --

Period for Reply

A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) OR THIRTY (30) DAYS, WHICHEVER IS LONGER, FROM THE MAILING DATE OF THIS COMMUNICATION.

- Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication.
- If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication.
- Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133). Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).

Status

- 1) ☐ Responsive to communication(s) filed on 02 April 2008.
- 2a) ☐ This action is **FINAL**. 2b) ☒ This action is non-final.
- 3) ☐ Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under *Ex parte Quayle*, 1935 C.D. 11, 453 O.G. 213.

Disposition of Claims

- 4) ☒ Claim(s) 1-8 is/are pending in the application.
- 4a) Of the above claim(s) _____ is/are withdrawn from consideration.
- 5) ☐ Claim(s) _____ is/are allowed.
- 6) ☒ Claim(s) 1-8 is/are rejected.
- 7) ☐ Claim(s) _____ is/are objected to.
- 8) ☐ Claim(s) _____ are subject to restriction and/or election requirement.

Application Papers

- 9) ☐ The specification is objected to by the Examiner.
- 10) ☒ The drawing(s) filed on 24 March 2004 is/are: a) ☒ accepted or b) ☐ objected to by the Examiner.
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).
Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).
- 11) ☐ The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.

Priority under 35 U.S.C. § 119

- 12) ☒ Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).
- a) ☒ All b) ☐ Some * c) ☐ None of:
1. ☒ Certified copies of the priority documents have been received.
2. ☐ Certified copies of the priority documents have been received in Application No. _____.
3. ☐ Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)).

* See the attached detailed Office action for a list of the certified copies not received.

Attachment(s)

- | | |
|--|---|
| 1) <input checked="" type="checkbox"/> Notice of References Cited (PTO-892) | 4) <input type="checkbox"/> Interview Summary (PTO-413) |
| 2) <input type="checkbox"/> Notice of Draftsperson's Patent Drawing Review (PTO-948) | Paper No(s)/Mail Date. _____ |
| 3) <input type="checkbox"/> Information Disclosure Statement(s) (PTO/SB/08) | 5) <input type="checkbox"/> Notice of Informal Patent Application |
| Paper No(s)/Mail Date _____ | 6) <input type="checkbox"/> Other: _____ |

DETAILED ACTION

Continued Examination Under 37 CFR 1.114

1. A request for continued examination under 37 CFR 1.114, including the fee set forth in 37 CFR 1.17(e), was filed in this application after final rejection. Since this application is eligible for continued examination under 37 CFR 1.114, and the fee set forth in 37 CFR 1.17(e) has been timely paid, the finality of the previous Office action has been withdrawn pursuant to 37 CFR 1.114. Applicant's submission filed on 4/2/08 has been entered.

Claim Rejections - 35 USC § 102

2. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless –

(a) the invention was known or used by others in this country, or patented or described in a printed publication in this or a foreign country, before the invention thereof by the applicant for a patent.

(b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.

(c) the invention was described in (1) an application for patent, published under section 122(b), by another filed in the United States before the invention by the applicant for patent or (2) a patent granted on an application for patent by another filed in the United States before the invention by the applicant for patent, except that an international application filed under the treaty defined in section 351(a) shall have the effects for purposes of this subsection of an application filed in the United States only if the international application designated the United States and was published under Article 21(2) of such treaty in the English language.

3. **Claims 1, 2, 3/1** are rejected under 35 U.S.C. 102(b) as being anticipated by Michael et al (US 6,421,458 B2).

Regarding **claim 1**, Michael discloses an image processing device for determining three-dimensional position and/or orientation of an object, comprising:

image data capturing means for capturing image data containing an image of the object (see figure 1a, numeral 100, col. 4, lines 31-45, imaging system 100);

reference model pattern creating means for creating a reference model pattern based on image data of a reference object with a three-dimensional reference orientation relative to said image capturing means captured by said image capturing means, said reference object having a shape substantially identical to that of the object (see fig. 2a, numeral 204, col. 4, lines 45-58; an alignment model image for the object is determined where the alignment model image 114 is selected from one of or part of the captured training images, the alignment model may comprise the entire training image itself or a portion of the training image containing interest features of the object);

transformation means for performing two-dimensional and geometrical transformation on the created model pattern using a plurality of parameter sets to generate a transformed model pattern representing an image of the object with three-dimensional orientation different from the reference orientation (see fig. 2a, numeral 210, col. 4, lines 59-67, col. 5, lines 1-65; alignment model image 114 and each training image 101 are presented to an alignment system 106 for determining the affine pose 107 of each training image with respect to the alignment model image and uses the affine pose 107 comprises a set of parameters which describe how the training image can be transformed mathematically so as to align the training image the alignment model image, each filtered training image 109 and its corresponding affine pose parameters 107

are applied to the General Affine Transform 110 to generate transformed training images 111, following transformation, a template image 113 is computed in step 212);

pattern matching means for performing a pattern matching of the image data of the object captured by said image capturing means with the transformed model pattern (see fig. 2b, numeral 234, col. 6, lines 35-67, col. 7, lines 1-8; generate a transformed image 311 which align substantially with the template images 113);

selecting means for repeatedly performing the generation of a transformed model pattern (see fig. 2a, numeral 216; col. 6, lines 8-20; a determination is made as to whether training is complete, if not additional training images may be captured) and the pattern matching of the image data of the object with the transformed model pattern to thereby select one of the transformed model patterns in conformity with the image data of the object, and obtain information on a position of the image of the object in the image data (see fig. 2b, numeral 234, col. 3, lines 5-10, col. 6, lines 35-67, col. 7, lines 1-8; process of transforming the filtered training and run-time images implies that the run-time process is executed more than once; generate a transformed image 311 which align substantially with the template images 113);

means for obtaining information on a position of the image of the object in accordance with the selected one of the transformed model patterns in the image data (see col. 3, lines 5-10, col. 6, lines 35-67, col. 7, lines 1-8; statistics on the area, position, and orientation of the labeled regions are computed);

means for obtaining information on the three-dimensional orientation of the object based on one of the parameter sets used for generating the selected one of the transformed model patterns (see col. 4, lines 7-18, col. 4, lines 66-67; col. 5, lines 1-17; affine parameters apply to

six degrees of freedom to compensate for image scale, shear, rotation, skew, and translation assuming a two-dimensional image of a three-dimensional object); and

determining means for determining three-dimensional position and/or orientation of the object based on the information on the position of the image of the object in the image data and information on the three-dimensional orientation of the object (see col. 3, lines 5-10, col. 6, lines 35-67, col. 7, lines 1-8; statistics on the area, position, and orientation of the labeled regions are computed).

Regarding **claim 2**, Michael discloses an image processing device for determining three-dimensional position and/or orientation of an object, comprising:

image data capturing means for capturing image data containing an image of the object (see figure 1a, numeral 100, col. 4, lines 31-45, imaging system 100);

reference model pattern creating means for creating a reference model pattern based on image data of a reference object with a three-dimensional reference orientation relative to said image capturing means captured by said image capturing means, said reference object having a shape substantially identical to that of the object (see fig. 2a, numeral 204, col. 4, lines 45-58; an alignment model image for the object is determined where the alignment model image 114 is selected from one of or part of the captured training images, the alignment model may comprise the entire training image itself or a portion of the training image containing interest features of the object);

transformation means for performing two-dimensional and geometrical transformation on the created model pattern using a plurality of parameter sets to generate a transformed model pattern representing an image of the object with three-dimensional orientation different from the

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reference orientation (see fig. 2a, numeral 210, col. 4, lines 59-67, col. 5, lines 1-65; alignment model image 114 and each training image 101 are presented to an alignment system 106 for determining the affine pose 107 of each training image with respect to the alignment model image and uses the affine pose 107 comprises a set of parameters which describe how the training image can be transformed mathematically so as to align the training image the alignment model image, each filtered training image 109 and its corresponding affine pose parameters 107 are applied to the General Affine Transform 110 to generate transformed training images 111, following transformation, a template image 113 is computed in step 212);

storage means for storing the plurality of transformed model patterns and the parameter sets used in generating the respective transformed model patterns to be associated therewith (see figure 1a, numeral 112, col. 5, lines 39-53; transformed training images are preferably stored in a pair of accumulators 112);

pattern matching means for performing pattern matching of the image data of the object captured by said image capturing means with the plurality of transformed model patterns to thereby select one of the transformed model patterns in conformity with the image data of the object (see fig. 2b, numeral 234, col. 6, lines 35-67, col. 7, lines 1-8; generate a transformed image 311 which align substantially with the template images 113); and

means for obtaining information on a position of the image of the object in accordance with the selected one of the transformed model patterns in the image data (see col. 3, lines 5-10, col. 6, lines 35-67, col. 7, lines 1-8; statistics on the area, position, and orientation of the labeled regions are computed);

means for obtaining information on the three-dimensional orientation of the object based on one of the parameter sets used for generating the selected one of the transformed model patterns (see col. 4, lines 7-18, col. 4, lines 66-67; col. 5, lines 1-17; affine parameters apply to six degrees of freedom to compensate for image scale, shear, rotation, skew, and translation assuming a two-dimensional image of a three-dimensional object); and

determining means for determining three-dimensional position and/or orientation of the object based on the information on the position of the image of the object in the image data and information on the three-dimensional orientation of the object (see col. 3, lines 5-10, col. 6, lines 35-67, col. 7, lines 1-8; statistics on the area, position, and orientation of the labeled regions are computed).

Regarding **claim 3/1**, Michael teaches a two-dimensional and geometrical transformation of an affine transformation (see col. 4, lines 66-67; col. 5, lines 1-17), and said image processing device further comprises additional measuring means for obtaining a sign of inclination of the object with respect to said image capturing means (see col. 4, lines 66-67; col. 5, lines 1-17).

Claim Rejections - 35 USC § 103

4. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negated by the manner in which the invention was made.

5. **Claims 7 and 8** are rejected under 35 U.S.C. 103(a) as being unpatentable over the combination of Michael et al (US 6,421,458 B2) in view of Watanabe et al (EP 1043689 A2).

Regarding **claims 7, 8**, Michael discloses all elements as mentioned above in claim 1. Michael does not disclose a storage means storing an operating orientation of the robot relative to the object or storing an operating orientation and an operating position of the robot relative to the object; and robot control means for determining an operating orientation of the robot or the operating orientation and an operating position of the robot based on the determined three-dimensional position and/or orientation of the object; and an image capturing means mounted on the robot.

Watanabe, in the same field of endeavor, teaches a storage means storing an operating orientation of the robot relative to the object or storing an operating orientation and an operating position of the robot relative to the object (“when a picking-up command is inputted three dimensional position/posture of the camera 20 on the world coordinate system at this image capturing position is outputted to the image processing apparatus 30”; Michael: paragraph [0040]); and robot control means for determining an operating orientation of the robot or the operating orientation and an operating position of the robot based on the determined three-dimensional position and/or orientation of the object (“robot controller 10 operates the robot to perform a pick-up operation based on the three-dimensional position/posture of the workpiece W (Step 210)”; Michael: paragraph [0044]); and an image capturing means mounted on the robot (Michael: figure 1, numeral 20).

It would have been obvious at the time the invention was made to one of ordinary skill in the art to modify the Michael reference, to be incorporated into a robot system as suggested by

Watanabe, to enhance inspection process by “demanding relatively less on system storage, and improv[ing] system speed and accuracy” (Michael: col. 2, lines 5-12).

6. **Claim 4** is rejected under 35 U.S.C. 103(a) as being unpatentable over the combination of Michael et al (US 6,421,458 B2) with Maeda et al (US 2003/0161537 A1), and further in view of Inoue (US 2003/0161504 A1).

Regarding **claim 4**, Michael discloses all elements as mentioned above in claim 3. Michael does not teach dividing of a model pattern into at least two partial model patterns which are subject to the affine transformation to generate transformed partial model patterns, and pattern matching of the image data of the object with the transformed partial model patterns to determine most conformable sizes, and determines the sign of the inclination based on comparison of the sizes of the conformable partial model patterns with each other.

Maeda teaches a pattern matching of the image data of the object with the transformed model patterns to determine most conformable sizes, and determines the sign of the inclination based on comparison of the sizes of the conformable model patterns with each other (Maeda: figure 1, numeral 32).

It would have been obvious at the time the invention was made to one of ordinary skill in the art to modify the Michael reference to determine the sign of the inclination based on comparison of the sizes of the conformable partial model patterns with each other as suggested by Maeda, to allow the imaging device to accurately identify “a three-dimensional object using images obtained by photographing the object in the various directions” (Maeda: paragraph [0004]).

The Michael with Maeda combination as applied above does not teach dividing of a model pattern into at least two partial model patterns which are subject to the affine transformation to generate transformed partial model patterns.

Inoue teaches dividing of a model pattern into at least two partial model patterns (Inoue: figure 2, numeral 302, 303), which are subject to the affine transformation (“affine transformation”; Inoue: paragraph [0107]) to generate transformed partial model patterns.

It would have been obvious at the time the invention was made to one of ordinary skill in the art to modify the Michael with Maeda combination as applied above, to utilize partial model patterns as suggested by Inoue, to further “correctly classify the input image regardless of a fluctuation in illumination, and a state of occlusion” (Inoue: paragraph [0012]).

7. **Claim 5** is rejected under 35 U.S.C. 103(a) as being unpatentable over Michael et al (US 6,421,458 B2) in view of Okisu et al (US 6,806,903 B1).

Regarding **claim 5**, Michael discloses all elements as mentioned above in claim 3. Michael does not teach a measurement of distances from a displacement sensor separately provided in the vicinity of said image capturing means to at least two points on the object using the displacement sensor, and determines the sign of the inclination based on comparison of the measured distances.

Okisu teaches a measurement of distances from a displacement sensor separately provided in the vicinity of said image capturing means to at least two points on the object using the displacement sensor, and determines the sign of the inclination based on comparison of the measured distances (“measure distance to two separate portions of an object from the electronic

camera, and calculate an angle of inclination θ based on measure two distances”; Okisu: col. 19, lines 54-57).

It would have been obvious at the time the invention was made to one of ordinary skill in the art to modify the Michael reference to determine the sign of the inclination based on comparison of the measured distances as suggested by Okisu, to allow the image processing device to properly focus with high degree of accuracy on the targeted object for image capturing.

8. **Claim 6** is rejected under 35 U.S.C. 103(a) as being unpatentable over Michael et al (US 6,421,458 B2) with Watanabe et al (EP 1043689 A2), and further in view of Maeda et al (US 2003/0161537 A1).

Regarding **claim 6**, Michael discloses all elements as mentioned above in claim 3. Michael does not teach additional pattern matching of image data of the object captured after said image data capturing means is slightly moved or inclined and determining the sign of the inclination based on judgment whether an inclination of image of the object becomes larger or smaller than the selected one of the transformed model patterns.

Watanabe, in the same field of endeavor, teaches an additional pattern matching of image data of the object captured after said image data capturing means is slightly moved or inclined (“camera may be moved parallelly in accordance with the position of the workpiece in the field of view of the camera”; Watanabe: paragraph: [0048]).

It would have been obvious at the time the invention was made to one of ordinary skill in the art to modify the Michael reference to move the image data capturing means as suggested by Watanabe, to provide more training images to the classifier in order for a more robust collection of data to enhance the classifier for increased reliability of the system.

Maeda teaches additional pattern matching of image data of the object captured after said image data capturing means is slightly moved or inclined (see fig. 4) and determining the sign of the inclination based on judgment whether an inclination of image of the object becomes larger or smaller than the selected one of the transformed model patterns (Maeda: figure 1, numeral 32).

It would have been obvious at the time the invention was made to one of ordinary skill in the art to modify the Michael with Watanabe combination to determine the sign of the inclination based on judgment whether an inclination of image of the object becomes larger or smaller than the selected one of the transformed model patterns as suggested by Maeda, to allow the imaging device to accurately identify “a three-dimensional object using images obtained by photographing the object in the various directions” (Maeda: paragraph [0004]).

Response to Arguments

9. Applicant's arguments with respect to **claims 1-3, 7, 8** have been considered but are moot in view of the new ground(s) of rejection.

Regarding **claims 4-6**, applicant argues that the claims are patentable because of the dependency from claim 1. This argument is not considered persuasive since a new grounds of rejection have been made and can be seen above in the rejection of claim 1.

Conclusion

10. Any inquiry concerning this communication or earlier communications from the examiner should be directed to EDWARD PARK whose telephone number is (571)270-1576. The examiner can normally be reached on M-F 10:30 - 20:00, (EST).

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Vikkram Bali can be reached on (571) 272-7415. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see <http://pair-direct.uspto.gov>. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

Edward Park
Examiner
Art Unit 2624

/Edward Park/
Examiner, Art Unit 2624

/Vikkram Bali/
Supervisory Patent Examiner, Art Unit 2624